

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY.'S DOCKET: NREL/96-48 V. Vannal

Applicant: Timothy A. Gessert

) Group Art: 1741 Serial No.: 08/937,721) Examiner: S. Mulpuri

Filing Date: September 25, 1997

Title: ION-BEAM TREATMENT TO PREPARE SURFACES OF

P-CdTe FILMS

AMENDMENT UNDER 37 C.F.R. § 1.116

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

In reply to the Official Action of November 11, 2000, which rejected the claims in the above-identified patent application, applicant respectfully request reconsideration, based upon the amendments hereinafter set forth.

IN THE CLAIMS:

Please cancel claims 2 and 3 without prejudice.

1. (Twice Amended) A dry process for making a low-resistance uniform and reproducible surface for electrical contact between a metal and a layer of polycrystalline p-type CdTe surface by ion beam processing comprising:

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